

Notice of References Cited	Application/Control No. 09/819,358	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Etienne P LeRoux	Art Unit 2171	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,506,393	04-1996	Ziarno, Witold A.	235/380
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	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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